Search Notes



Application/Contr	ol No.	Applicant(s)/Patent under Reexamination	
10/052,256		TERUUCHI ET	AL.
Examiner		Art Unit	
Chau Nguyen		2176	

	SEARCHED					
Class	Subclass	Date	Examiner			
715	513	8/31/2006	CN			
715	514	8/31/2006	CN			
715	531	8/31/2006	CN			
713	176	8/31/2006	CN			
713	179	8/31/2006	CN			
713	180	8/31/2006	CN			
713	189	8/31/2006	CN			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East Reports	12/15/2004	CN		
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	12/17/2004	CN		
Updated Search on East Reports	8/23/2005	CN		
Updated Search on East Reports	02/07/2006	CN		
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	02/09/2006	CN		
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